

IPW



SE-US045044

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Kazuaki SAKURADA :  
Serial No.: 10/796,276 :  
Filed: March 10, 2004 :  
For: APPARATUS AND METHOD FOR :  
FABRICATING FUNCTIONAL FILM :

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents  
Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant brings the references listed on the attached PTO-1449-Form to the Examiner's attention and requests that they be considered and made of record in this application. Copies of the non-U.S. patents are attached. This Information Disclosure Statement is being filed within three (3) months of the filing date of this application. Thus, *no fee is believed to be due for this Information Disclosure Statement*. However, the Commissioner is authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

\* \* \*

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

Yoshio Miyagawa  
Reg. No. 43,393

SHINJYU GLOBAL IP COUNSELORS, LLP  
1233 Twentieth Street, NW, Suite 700  
Washington, DC 20036  
(202)-293-0444

Dated: Jun/8/04  
G:\06-JUN04-AO\SE-US045044\IDS.doc

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. **DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:** Assistant Commissioner for Patents, Washington, DC 20231.